

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Confirmation No.: 9428
Shunpei YAMAZAKI , et al.)
Serial No. 10/678,139) Examiner: Mary A. Wilczewski
Filed: October 6, 2003) Group Art Unit: 2822
For: METHOD FOR FABRICATING)
SEMICONDUCTOR THIN FILM)

AMENDMENT

United States Patent and Trademark Office
Customer Service Window, **Mail Stop Amendment**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated April 4, 2011, please consider Applicants' remarks as follows.

A Listing of the Claims begins on page 2 of this paper.

Remarks begin on page 7 of this paper.